



Docket No. 740819-430

Serial No. 09/680,054

Page 1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shinji NAKAMURA et al.

Serial No. 09/680,054

Filed: October 5, 2000

For: SEMICONDUCTOR DEVICE,
SEMICONDUCTOR SUBSTRATE,
AND MANUFACTURE METHOD

)

) Group Art Unit: 2823

) Examiner: Brook Kebede

) Confirmation No. 7323

) Date: September 5, 2003

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CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Mail Stop Non-Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at _____, on September 5, 2003.

Signature: _____

Name: Deborah Movahhedi

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 5, 2003, please amend the above identified application as follows.

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